

Thursday 6 November

09:00

Workshop on Laser processing of materials for advanced optoelectronic applications

Session

Location: Zoom and Faculty of Physics, Taras Shevchenko National University of Kyiv, Kyiv, Ukraine, Room 261(Laboratory building), The conference will be performed in HYBRID mode: - On-site at Faculty of Physics of Trars Shevchenko National University of Kyiv - Vla ZOOM platform

Convener: Dr Danylo Babich

09:00-09:30

Direct optical lithography and scanning laser processing of materials for advanced optoelectronic applications

Speaker

Prof. Volodymyr Dzhagan

09:30-09:45 Ultrashort Pulse Laser Microfabrication Technologies at FTMC

Speaker

Dr Andrius Žemaitis

09:45-10:00

Single-Pulse Nanosecond Laser Patterning of Nanoscale Electronic-Structural Landscapes in GeSn

Speaker

Dr Petro Lytvyn

10:00-10:15 Laser reduction of Graphene Oxide films on SiO2-Si structures

Speaker

Prof. Alexei N. Nazarov

10:15-10:30 Formation and Properties of GeSn and GeSn:C Films

Speaker

Prof. Volodymyr Yukhymchuk

10:30-10:45

Fabry-Pérot Enhanced THz Sensitivity of Antenna-Coupled HgCdTe Detectors

Speaker

Prof. Zinoviia Tsybrii

10:45-11:00

Photoinduced formation of semiconductor nanocrystals in amorphous arsenic chalcogenides

Speaker

Dr Yuriy Azhniuk

11:00